

10/768,568

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2496		Priority SERIAL NO. 097945,137	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Jerome Eldridge			
				Priority FILING DATE August 30, 2001		Priority GROUP 2822	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
KBD ↓	AA	5,350,738	9/94	Hase et al			
	AB	5,272,341	12/93	Micheli et al			
	AC	5,142,437	08/92	Kammerdiner et al			
	AD	6,461,931	10/02	Eldridge			
	AE	6,025,257	02/00	Jeon, Yoo Chan			
	AF	5,789,268	08/98	Chivukula			
	AG	6,481,831	10/02	Eldridge			
	AH	6,403,441	06/02	Takehiro et al			
	AI	5,953,619	09/99	Miyazawa			
	AJ						
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
KBD ↓	AK	EP 0727832 A1	08/96	EPO/Miyashita et al			
	AL						
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	AN						
	AP						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
KBD ↓	AP		John Baliga, "New Materials Enhance Memory Performance", Semiconductor International, November 1999, pgs. 1-8.				
	AQ		Advances in Ultrathin Oxides and Oxynitrides I, Materials Research Society Symposium Proceedings Series, Vol. 567,, April 5, 1999, 2 pages.				
	AR		K.S. Tang, W.S. Lau, and G.S. Samudra, "Trends in Dram Dielectrics", IEEE Circuits & Devices, Vol. 13, No. 3, May 1997, pgs. 27-34				
EXAMINER				DATE CONSIDERED			
John W. B. Jones				8/22/2004			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

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	AM						
	AN						
	AO						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
<div style="font-size: 2em; font-family: cursive;">KBD</div> <div style="font-size: 2em; font-family: cursive;">↓</div>	AP		D.W. Hess, "Plasma-assisted oxidation, anodization, and nitridation of silicon", IBM Journal of Research & Development, Vol. 43, No. 1/2, Plasma processing, 22 pages.				
<div style="font-size: 2em; font-family: cursive;">↓</div>	AQ		O. Kubaschewski, E. LL. Evans, "Metallurgical Thermochemistry", Pergamon Press, 1958, pgs. 226-227 and 336-337				
<div style="font-size: 2em; font-family: cursive;">↓</div>	AR		Ting, Chen, Liu, "Structural evolution and Optical properties of TiO <sub>2</sub> thin films prepared by thermal oxidation of sputtered Ti films", Journal of Applied Physics, Vol. 88, Number 9, 15 October 2000, pgs.4628-4633.				
EXAMINER				DATE CONSIDERED			
<div style="font-size: 1.5em; font-family: cursive;">John B. Dwyer</div>				<div style="font-size: 1.5em; font-family: cursive;">8/22/2004</div>			
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes    No
	AK						
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	AM						
	AN						
	AO						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
<div style="font-size: 2em; font-family: cursive;">KBD</div> <div style="font-size: 3em; font-family: cursive;">↓</div>	AP		O. Kubaschewski, B.E. Hopkins, "Oxidation of Metals and Alloys", Butterworths, London, Second Edition, 1962, pgs. 36-37 and 70-73.				
	AQ		F.P. Fehlner, "Low-Temperature Oxidation", Monograph published by Electrochemical Society, Pennington, New Jersey, 1983, pgs.31-35.				
<div style="font-size: 2em; font-family: cursive;">↓</div>	AR		Richard A. Swalin, "Thermodynamics of Solids" Second Edition, Chpt 5, John Wiley & Sons, 1972, pgs. 112-115.				
EXAMINER <div style="font-size: 1.5em; font-family: cursive;">John R. T. Roy</div>				DATE CONSIDERED <div style="font-size: 1.5em; font-family: cursive;">8/22/2004</div>			
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